

10/074293

[illegible]

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Substitute for form 1449A/PTO		Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	
		Filing Date	
		First Named Inventor	Harry Contopanagos
		Group Art Unit	
		Examiner Name	
Sheet	2	of	2
		Attorney Docket Number	BP 2108

Examiner Initials	Cite No 1	Indicate name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the book, magazine, journal, symposium, catalog, etc., date, page(s), volume-issue number(s), publisher, city and/or country where published	
	1	"PROGRESS IN RF INDUCTORS ON SILICON - UNDERSTANDING SUBSTRATE LOSSES" by Joachim N. Burghartz - IBM Research Division, T. J. Watson Research Center, P. O. Box 218, Yorktown Heights, New York 10598 USA	<input type="checkbox"/>
	2	IEEE Journal of Solid-State Circuits, Vol. 33, No 5, May 1998 - the "Stanford Paper" - "ON-CHIP SPIRAL INDUCTORS WITH PATTERNED GROUND SHIELDS FOR Si-BASED RF IC's - C. Patrick Yue, Student Member, IEEE, and S. Simon Wong, Senior Member, IEEE	<input type="checkbox"/>
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Examiner Signature	/Leonardo Andujar/	Date Considered	11/14/2008
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